## Micro-Gass<sup>™</sup> Gas Analysis Sampling System

## Eliminate Condensation Problems When Analyzing With Electro-Chemical Sensors

- 20-80% RH sample outlet
- Built-in sample pump
- 0.1 µ particulate filter
- NEMA 4X housing

- Low maintenance
- Corrosion resistant
- Nafion<sup>®</sup> drying technology
- Samples up to 1.2 lpm

Perma Pure Micro-GASS<sup>™</sup> sample conditioning systems prepare gas samples for use with electrochemical sensors (ECS). In moisture-saturated samples, sensor life is greatly reduced due to condensation within the cell and subsequent leakage of electrolyte. Micro-GASS systems eliminate this problem by removing excess water.

## **Principle of Operation**

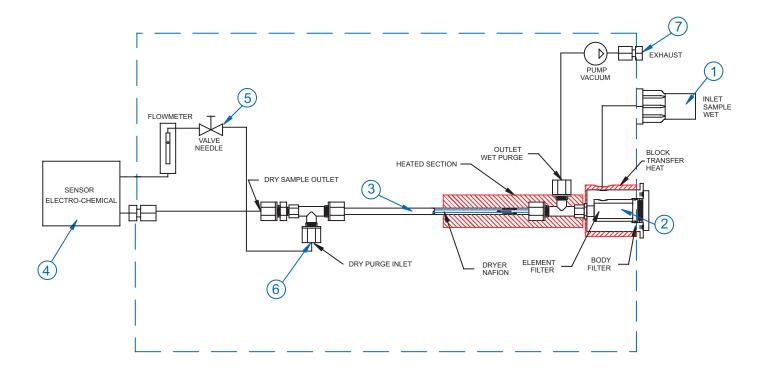
Micro-GASS units offer full corrosion resistance and very high selectivity, so complex samples can be processed without loss of analyte gases. Nafion® dryer technology is the driving force behind this system. Operating as a self-contained unit, the Micro-

GASS incorporates a built-in pump to draw the sample gas through a temperature- controlled filter and MD-Series<sup>™</sup> Nafion dryer. Dried sample then flows to the sensor where the measurement is made. After exhausting from the ECS, the gas passes through a needle valve and expands, causing a reduction in vapor pressure. It then re-enters the dryer to be used as a purge gas. Because the purge gas is generated from the exhaust stream of the sensor, the

Micro-GASS is a self-regenerating and transportable conditioning system, relying only on a power source.

| Model Number              | UG-1212-F1                                     |
|---------------------------|--|
| Enclosure                 | 12" w x 12"h x 7"d<br>NEMA 4X with clear cover |
| Sample Flow Rate          | 0.5 to 1.2 lpm                                 |
| Max. Inlet Water Content  | 55°C dew point; 15% by volume                  |
| Gas Inlet/Outlet Fittings | 1/4" tube compression                          |





| Figure # | Description  |  |
|----------|--|--|
| 1        | Sample inlet - A built-in pump draws the sample into the enclosure                       |  |
| 2        | Particulate filter - A heated filter removes 95% of 0.1µ particles                       |  |
| 3        | Nafion membrane dryer - A heated dryer removes moisture                                  |  |
| 4        | Sensor - Dried sample flows into the analyzer  |  |
| 5        | Needle valve - Analyzer exhaust goes through a needle valve, lowering the vapor pressure |  |
| 6        | Purge - The gas then re-enters the dryer as the purge gas                                |  |
| 7        | Exhaust - The purge gas exhaust vents to a safe environment                              |  |

| System Specifications  |  |
|------------------------|--|
| Temperature            | 65°C (150°F) max.  |
| Pressure               | -5 inches of Hg min.<br>30 psig max.                       |
| Electrical Requirement | 110 VAC, 0.6 amps, 60 watts<br>220 VAC, 0.3 amps, 60 watts |

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